

FORM PTO-1449 MODIFIED		Docket No.: 2437.09US04		Application No.: 10/077,180		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		APPLICANT: HIATT et al.				
		FILING DATE: February 15, 2002				
		GROUP ART UNIT: 3729				
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
HNT	3,614,554	10/1971	Shield et al.	—	—	
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	5,420,558	05/1995	Ito et al.	—	—	
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EXAMINER SIGNATURE				DATE CONSIDERED		7/11/05
A. DEXTER TUOBANS PRIMARY EXAMINER						
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OTHER DOCUMENTS			
Examiner Initials	(Author, Title, Date, Pertinent Pages, etc.)		
WMT	Park et al., "High Current Integrated Microinductors and Microtransformers using Low Temperature Fabrication Processes," <i>SPIE Proceedings</i> Vol. 2920, 1996 International Symposium on Microelectronics, Minneapolis, Minnesota, USA, October 1996.		
	Park et al., "A Comparison of Micromachined Inductors with Different Magnetic Core Materials," <i>IEEE 46<sup>th</sup> Electronic Components &amp; Technology Conference</i> , Orlando, FL, pp. 375-381, 1996.		
	Ahn et al., "A Planar Micromachined Spiral Inductor for Integrated Magnetic Microactuator Applications," <i>J. Micromech. Microeng.</i> , Volume 3, pp. 37-44, 1993.		
	Ahn et al., "A Planar Variable Reluctance Magnetic Micromotor with Fully Integrated Stator and Coils," <i>Journal of Microelectromechanical Systems</i> , Volume 2, No. 4, pp. 165-173, December 1993.		
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WMT	Frazier et al., "Development of Micromachined Devices Using Polyimide-Based Processes," <i>Sensors and Actuators A</i> 45, pp. 47-55, 1994.		
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